



FPD Materials & Components Japan TC Chapter Meeting

Japan Standards Autumn Meetings 2026

Friday, October 9, 2026

SEMI Japan Office, Tokyo, Japan / Official Virtual TC Chapter Meeting (Hybrid)

3:00 PM - 5:00 PM JST

AGENDA

1 Welcome/Call to Order

- 1.1 Introduction
- 1.2 Required Elements (Membership Requirements, Antitrust and Intellectual Property Reminders, and Effective Meeting Guidelines)
- 1.3 Agenda Review

2 Review of Previous Meeting Minutes

3 Liaison Report

- 3.1 Japan Regional Standards Committee (JRSC)
- 3.2 Global Coordinating Subcommittee (GCS)

4 Staff Report

5 Ballot Review

6 Subcommittee & Task Force Reports

- 6.1 Flexible Display Task Force
- 6.2 FPD Mask Task Force
- 6.3 FPD Materials & Components Maintenance Task Force

7 Old Business

7.1 Project Period Review

7.2 5-Year Review

- SEMI D74-1121, Guide for Measuring Dimensions of Plastic Films/Substrates
- SEMI D50-0822, Test Method for Surface Hardness of FPD Polarizing Film

8 New Business

- SNARF Approval
 - Revision to SEMI D78-0224, Test Method of Water Vapor Barrier Property for Plastic Films with High Gas Barrier for Electronic Devices.
 - New Standard
- Ballot Submission
 - Revision to SEMI D78-0224, Test Method of Water Vapor Barrier Property for Plastic Films with High Gas Barrier for Electronic Devices.

9 Action Item Review

9.1 Open Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>
FPDM&C_202603 19_01	SEMI Staff	To forward the ballot adjudication result of Doc.#7383, 7384, 7403, 7404, 7412 and 7413 to ISC A&R Subcommittee for procedural review.
FPDM&C_202603 19_02	Co-chairs	To recommend Keitaro Kondo (HOYA) to be the new Co-chair to the JRSC.

9.2 New Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>

10 Next Meeting and Adjournment

10.1 The next meeting is scheduled for <date> at <event/location>.